MgZnO p–n heterostructure light-emitting devices

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MgZnO heterostructure light-emitting devices (LEDs) have been fabricated from p-Mg0.35Zn0.65O/n-Mg0.20Zn0.80O structures, and the p-type Mg0.35Zn0.65O film was realized using a lithium–nitrogen codoping method. Obvious ultraviolet emission peaked at around 355 nm dominates the electroluminescence (EL) spectra of the device at room temperature, which comes from the near-band-edge emission of the n-type Mg0.20Zn0.80O film. This is the first report on MgZnO heterostructured LEDs and the shortest EL emission ever reported in ZnO-based p–n junction LEDs to the best of our knowledge. © 2013 Optical Society of America

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Ultraviolet (UV) semiconductor photonic devices such as light-emitting devices (LEDs) and laser diodes have attracted considerable attention in recent years for their versatile applications such as efficient lighting, sterilization, water purification, medical diagnostics, and so forth [1,2]. Because of its wide direct bandgap and large exciton binding energy, ZnO has been considered as one of the most promising candidates for UV LEDs [3–5]. Some reports have demonstrated ZnO-based p–n junction LEDs recently [6–8]. Nevertheless, considering that efficient p-type doping of ZnO is still a huge challenge, many researchers have devoted effort to ZnO-based heterojunction LEDs by combining n-ZnO with other p-type materials, such as p-GaN [9] and p-SiC [10], etc. It is accepted that due to the large difference in the physical properties and chemical bonding states of the two materials, surface defects will usually form at the interface, which will degrade the performance of the heterojunction LEDs drastically. Heterostructures constituted by alloyed semiconductors with different composition can ensure efficient carrier injection and confinement, thus they are effective in improving the performance of LEDs. Nevertheless, the reports on ZnO-based heterostructured LEDs are still very limited [11–13]. Another interesting character of ZnO lies in its tunable bandgap when alloyed with MgO, which implies that ZnO-based materials may find applications in shorter-wavelength LEDs [14–16]. However, the emissions of the ZnO-based LEDs reported so far are all located in the region longer than 375 nm, which corresponds to the near-band-edge emission of ZnO, while no report on shorter-wavelength ZnO-based LEDs can be found up to now.

In a previous study, reproducible p-type ZnO films have been realized, and reliable ZnO-based p–n junction LEDs that can operate continuously for several hours have been fabricated [17,18]. In this Letter, by employing a lithium nitrogen (Li,N) codoping method, p-type Mg0.35Zn0.65O films have been prepared, and p-Mg0.35Zn0.65O/n-Mg0.20Zn0.80O heterostructured LEDs have been fabricated. Dominant UV emission peaked at around 355 nm has been observed from the heterostructures.

The MgZnO films investigated in this study were grown on a-plane sapphire in a VG V80H plasma-assisted molecular beam epitaxy technique. First, a 400 nm n-type Mg0.20Zn0.80O film was grown onto the sapphire substrate; the detailed growth conditions can be found elsewhere [19]. After that, Li,N-codoped p-type Mg0.35Zn0.65O film was deposited onto the n-type Mg0.20Zn0.80O film to form the heterostructure. For the p-type doping of the Mg0.35Zn0.65O, elemental Zn, Li, and Mg contained in individual Knudsen cells were employed as precursors, and atomic oxygen and nitrogen generated from NO gas (6N) via a plasma cell was used as the O and N source. The growth chamber pressure and substrate temperature were set at 1.5 × 10−3 mbar and 700°C during the growth, respectively. Metallic In and Ni/Au layers were deposited onto the n-Mg0.20Zn0.80O and Mg0.20Zn0.80O: (Li, N) layers acting as ohmic contacts by a thermal evaporation method.

The electrical properties of the films were measured by a Hall system. The composition of the MgZnO layers was determined using energy dispersive x-ray spectroscopy (EDS). An AXIS Ultra DLD x-ray photoelectron spectroscopy (XPS) has been employed to measure the doping concentration of the dopants. The photoluminescence (PL) spectra of the n-Mg0.20Zn0.80O films were recorded using the 325 nm line of an He–Cd laser as the excitation source, and those of the Mg0.35Zn0.65O layer were carried out under the excitation of the 266 nm line of a YAG:Nd laser. EL measurements of the heterostructured LEDs were carried out in a Hitachi F4500 spectrometer under the drive of a continuous-current power source.

The electron concentration and Hall mobility of the n-type Mg0.35Zn0.65O film are 2.7 × 1019 cm−3 and 23 cm2/Vs, respectively. Such a low resistivity is favorable for constructing light-emitting structures. The Li and N concentration in the Mg0.35Zn0.65O: (Li, N) film determined by XPS is around 1.84% and 0.43%, respectively. Hall measurement on the Mg0.35Zn0.65O: (Li, N) film shows p-type conduction with a hole concentration of about 1.6 × 1016 cm−3 and a mobility of 1.3 cm2/Vs. The formation mechanism of Li,N-codoped p-type ZnO-based films have been investigated before [17,20], and...
it has been speculated that Li substituted Zn(Mg) (Li$_{2}$Zn(Mg)) acts as acceptors, while the incorporated N may passivate the interstitial Li donors to reduce the possible compensation to Li$_{2}$Zn(Mg) acceptors.

The structural properties of the MgZnO films characterized by x-ray diffractometer (XRD) are shown in Fig. 1. Only one strong peak at 34.61° and 34.69° can be observed from the patterns of the n-type and p-type layers, respectively, which reveals that both the films are crystallized in a hexagonal wurtzite structure with (0002) preferred orientation. The larger angle of the p-type layer than the n-type layer indicates higher Mg composition of the p-type layer, which is consistent with the EDS data.

To assess the optical properties of the MgZnO layers, absorption and PL spectra of these layers have been measured, the results of which are shown in Fig. 2. One can see from Fig. 2(a) that the n-Mg$_{0.20}$Zn$_{0.80}$O film shows a strong absorption in the UV region with a sharp absorption edge at around 344 nm. From the absorption spectrum, a band gap of around 3.60 eV can be derived for the n-Mg$_{0.20}$Zn$_{0.80}$O film by employing the $\alpha^2 \propto (h\nu-E_g)$ expression, where $\alpha$ is the absorption coefficient and $h\nu$ is the photon energy. The PL spectrum of the n-Mg$_{0.20}$Zn$_{0.80}$O layer displays a strong Gaussian line-shape peaked at around 349 nm, which can be attributed to the near-band-edge emission of the Mg$_{0.20}$Zn$_{0.80}$O film. The absorption edge of the Mg$_{0.35}$Zn$_{0.65}$O:(Li, N) layer is located at around 330 nm, as shown in Fig. 2(b), from which a band gap of around 3.75 eV can be derived. The PL spectrum of the Mg$_{0.35}$Zn$_{0.65}$O:(Li, N) shows a broad emission peak at around 336 nm. The broadening of the PL spectrum may come from the composition fluctuation in this layer.

The current–voltage (I–V) curve of the heterostructure is illustrated in Fig. 3. Obvious rectifying behaviors are observed in the I–V curve. The turn-on voltage of the structure is about 6.0 V. Note that the sheet resistance of the structure deduced from the I–V curve is around 252Ω. Shown in the inset of Fig. 3 is the I–V curve of the Ni–Au electrode on the p-type Mg$_{0.35}$Zn$_{0.65}$O:(Li, N) layer and the In electrode on the n-type Mg$_{0.20}$Zn$_{0.80}$O layer. The linear I–V curves reveal that ohmic contacts have been obtained in both cases. The ohmic behaviors of the metal contacts exclude the possibility of the formation of any Schottky junction in the device, confirming the rectification behaviors arise from the heterostructure.

The room-temperature EL spectra of the p-Mg$_{0.35}$Zn$_{0.65}$O:(Li, N)/n-Mg$_{0.20}$Zn$_{0.80}$O heterostructure at various injection currents are shown in Fig. 4. All the spectra are dominated by an emission band peaked at around 355 nm, which can be attributed to the near-band-edge emission of the n-Mg$_{0.20}$Zn$_{0.80}$O as its position

![Fig. 1. XRD pattern of the (a) n-type Mg$_{0.20}$Zn$_{0.80}$O and (b) p-type Mg$_{0.35}$Zn$_{0.65}$O:(Li, N) layers grown on α-plane sapphire.](image)

![Fig. 2. Normalized absorption and PL spectra of the (a) n-type Mg$_{0.20}$Zn$_{0.80}$O layer and (b) p-type Mg$_{0.35}$Zn$_{0.65}$O:(Li, N) layer.](image)

![Fig. 3. I–V characteristics of the p-Mg$_{0.35}$Zn$_{0.65}$O:(Li, N)/n-Mg$_{0.20}$Zn$_{0.80}$O heterostructure; the inset shows the I–V curves of the Ni/Au contact on the p-type layer and the In contact on the n-type layer.](image)

![Fig. 4. Room-temperature EL spectra of the p-Mg$_{0.35}$Zn$_{0.65}$O:(Li, N)/n-Mg$_{0.20}$Zn$_{0.80}$O heterostructure at different injection currents.](image)
is very close to the PL peak of this layer (349 nm). Additionally, a broad emission at around 500 nm can also be observed from the EL spectra, which has been frequently observed in ZnO-based LEDs [15, 21], and may come from the deep-level-related emission in ZnO-based materials. We note that the defects-related emission does not appear in the PL, while it does in the EL spectra of the heterostructure. The reason for the discrepancy may be as follows: In EL the recombination of electrons and holes occur at the p-MgO20Zn50O0/80O(n-MgO20Zn50O0/80O interface, while the interface usually has a relatively high defect density. Consequently, deep-level-related emission is observed in the EL spectra. Meanwhile, PL emission comes from the n-type or p-type layer but not from the interface, where the defect density inside the layers is usually much lower than that at the interface. As a result, in our case even though there is no defect-related emission in PL, defect-related EL emission has been observed. This is the first report on MgZnO heterostructured LEDs and the shortest EL emission ever reported in ZnO-based p-n junction LEDs to the best of our knowledge. The results reported in this paper may promise short UV or even deep ultraviolet LEDs from MgZnO-based materials.

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